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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE SUPPLEMENTAL INFORMATION DISCLOSURE Docket Number: **STATEMENT** 52433/664 Application Number Filing Date Examiner Art Unit 10/030,368 October 25, 2001 Elvis O. Price 1621 Title Applicant(s) PROCESS FOR PRODUCTION OF FORMATE K. FUJIMOTO et al. ESTERS OR METHANOL AND CATALYST **THEREFOR**

Address to: Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to:

Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Date: August 23, 2005 Reg. No. 29, 182
Signature: Sikn J. Killy &

JOHN J. KELLY JN

1. In accordance with the continuing duty of disclosure under 37 C.F.R. § 1.56 and in conformance with the procedures of 37 C.F.R. §§ 1.97 and 1.98 and M.P.E.P. § 609, attorney(s) for Applicant(s) hereby bring the reference(s) listed on the attached modified PTO Form No. 1449 to the attention of the Examiner. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the reference(s) be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- 2. A copy of each patent, publication or other information listed on the modified PTO form 1449 is enclosed, except as otherwise indicated.
- 3. In accordance with the Official Gazette of August 5, 2003, which stated that the United States Patent and Trademark Office waived the requirement under 37 C.F.R. § 1.98 (a)(2)(i) for submitting a copy of each cited U.S. patent and each U.S. patent application publication for all U.S. patent applications filed after June 30, 2003, copies of each of the cited U.S. patents and U.S. patent application publications are not being provided.
- 4. Pursuant to 37 C.F.R. § 1.97(c) and § 1.97(e), Applicants' attorney certifies that each item of information contained in this Supplemental Information Disclosure Statement was first cited in a communication dated June 28, 2005 from a foreign patent office in a counterpart foreign (Europe) patent application not more than three months prior to the filing of this Supplemental Information Disclosure Statement.
- 5. It is believed that no fees are due in connection with this Supplemental Information Disclosure Statement. However, should any fees be due, the Commissioner is authorized to charge Deposit Account No. 11-0600 for such fees. A duplicate copy of this communication is enclosed for charging purposes.

Dated: August 23, 200)

By: John J. Kelly, Jr. (Reg. No. 29,182)

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SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT BY APPLICANT PTO-1449

_	DOCKET NO.	SERIAL NO.	
	52433/664	10/030,368	
	APPLICANT		
	K. FUJIMOTO et al.		
	FILING DATE	GROUP	
	October 25, 2001	1621	

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE
	5,384,335	January 24, 1995	Tierney et al.			

FOREIGN PATENT DOCUMENTS

						TRANSLATION	
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Yes	No
	863 046	January 15, 1953	Germany				
	926 785	April 25, 1955	Germany				

OTHER DOCUMENTS

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.			
	Palekar et al., "Alkali compounds and copper chromite as low-temperature slurry phase methanol catalysts", Applied Catalysts A: General, 103:105-122 (1993)			
	Yingchun et al., "Phase transfer preparation of Cu-Mn catalyst for methyl formate synthesis directly from synthesis gas", Huaxue Yanjiu Yu Yingyong, 12:510-513 (2000) (Chemical Abstracts Service)			

EXAMINER	PATE CONGIDENCE	٠
EXAMINER	DATE CONSIDERED	

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.